



IFW

PATENT
Customer No. 22,852
Attorney Docket No. 03327.2343-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Sei UMISED0 et al.) Group Art Unit: Unassigned
)
Application No.: Unassigned 10574281) Examiner: Unassigned
)
Filed: March 31, 2006)
)
For: ION BEAM MEASURING)
METHOD AND ION IMPLANTING)
APPARATUS)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application
as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims as reflected in the listing of claims begin on page 3
of this paper.

Remarks/Arguments begin on page 17 of this paper.